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List of Patents and Publications for Applicant's

INFORMATION DISCLOSURE STATEMENT

Applicant

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Group:

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(Use several sheets if necessary)

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EXAMINER: /Michael Keefer/

DATE CONSIDERED: 12/15/2006

EXAMINER: INITIAL IF REFERENCE CONSIDERED, WHETHER OR NOT CITATION IS IN CONFORMANCE WITH MPEP609; DRAW LINE THROUGH CITATION IF NOT IN CONFORMANCE AND NOT CONSIDERED. INCLUDE COPY OF THIS FORM WITH NEXT COMMUNICATION TO APPLICANT.

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